Product name:	Product code:
Optical Motion Control Training System	CMI-NP-1778



Description

Optical Motion Control Training System is a system where a stepper stage positions optical elements using sensors and a controller.

Technical specification

Light source	LED and diode laser < 1 mW

Standard Accessories

- Lens set
- Fibre cable
- Experiment manual

The Optical Motion Control Training System is a system where a stepper stage positions optical elements using sensors and a controller. It is designed for training in opto-electronic components, light-based measurement and optical devices combined with mechatronic control.

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Features

- Safe low-power laser and LED sources
- Digital readouts for easy data recording
- Optical bench with movable carriers
- Combines optics with sensors and actuators

Technical Specifications

Travel	100 mm
Resolution	0.01 mm
Controller	Microcontroller with LCD
Supply	230 V AC, 50 Hz, single phase
Optical bench	1000 mm rail